



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Fumikazu YAMAKI et al.

Serial No.: 10/035,444

Filed: January 4, 2002

Group Art Unit: 2826

Examiner: Tan N. Tran

P.T.O. Confirmation No.: 3015

For: SEMICONDUCTOR DEVICE WITH A SUPER LATTICE BUFFER

RESPONSE UNDER 37 C.F.R. §1.116
- EXPEDITED RESPONSE -
GROUP ART UNIT 2826

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 30, 2003

Sir:

In response to the Office Action dated **June 30, 2003**, please amend the above-captioned patent application as follows:

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GP 2826
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